

Substitutes for form 1442/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Complete if Known	
		Application Number	10/606,022
Sheet 1 of 1		Filing Date	June 24, 2003
		First Named Inventor	Boyd
		Art Unit	1746
		Examiner Name	Unassigned Perrin
		Attorney Docket Number	LAM2P425

U.S. Patent Documents

Examiner Initials	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear
<i>JP</i>	A	2004/136494 0136494	07/15/2004	Isari, et al. 60f	
	B				
	C				
	D				
	E				
	F				
	G				
	H				

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5/21/07

Foreign Patent Documents

Examiner Initial	Cite No. ¹	Foreign Patent Document No. Country Code ² -Number-Kind Code ³ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear	T ⁴
<i>JP</i>	I	WO 99/49504	9/1999	Nikon Corp.		<input type="checkbox"/>
<i>JP</i>	J	EP 1 489 461	EP 12/2004	ASML Netherlands B.V.		<input type="checkbox"/>
<i>JP</i>	K	EP 1 489 462	EP 12/2004	ASML Netherlands B.V.		<input type="checkbox"/>
	L					<input type="checkbox"/>
	M					<input type="checkbox"/>

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5/11/07

Non Patent Literature Documents

Examiner Initial	Cite No.	Include name of author (in CAPITAL LETTERS), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published
<i>JP</i>	N	International Search Report mailed 08 February 2005.
<i>JP</i>	O	Owa, et al., "Immersion Lithography; Its Potential Performance and Issues," <i>Proceedings of the SPIE, SPIE, Bellingham, VA</i> , Vol. 5040, No. 1, February 28, 2003, pp. 724-33, XP002294500, ISSN: 0277-786X

Examiner Signature	<i>JP Perrin</i>	Date Considered	7/5/06
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Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language translation is attached.